

Notice of References Cited	Application/Control No. 10/734,755	Applicant(s)/Patent Under Reexamination CHIEN ET AL	
	Examiner RICARDO L. OSORIO	Art Unit 2629	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2005/0157971	07-2005	Juijve et al.	385/012
*	B	US-6,776,497	08-2004	Huppi et al.	362/85
*	C	US-6,179,432	01-2001	Zhang et al.	362/84
*	D	US-5,397,867	03-1995	Demeo, Gregory B.	200/5A
*	E	US-5,097,396	03-1992	Myers, J. Michael	362/551
*	F	US-6,987,466	01-2006	Welch et al.	341/22
*	G	US-6,609,805	08-2003	Nelson, Michael T.	362/30
*	H	US-2003/0090885	05-2003	Hsu, Chen-Chang	362/24
*	I	US-6,897,912	05-2005	Kawakami et al.	349/61
*	J	US-6,023,277	02-2000	Osaka et al.	345/419
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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